



Docket No.: 8733.154.00-US  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Jin Jang, et al

Application No.: 09/350,313

Filed: July 9, 1999

For: METHOD OF CRYSTALLIZING  
AMORPHOUS SILICON LAYER AND  
CRYSTALLIZING APPARATUS THEREOF

Group Art Unit: 1765

Examiner: R. Kunemund

#23/c  
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TC 1700

AMENDMENT UNDER 37 CFR 1.116

Box AF  
Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In response to the Office Action dated December 16, 2002 (Paper No. 22), finally rejecting claims 1-19, 22, and 24-41 please amend the above-identified U.S. patent application as follows:

In the Claims

Please cancel claims 14 and 15 without prejudice or disclaimer.

Please amend the claims as follows (A marked-up copy of the amended claims is attached):

1. (Amended) A method of crystallizing amorphous silicon, comprising:  
depositing an inducing substance for silicon crystallization on an exposed surface of an amorphous silicon layer by plasma exposure; and  
annealing the amorphous silicon layer,



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<b>AMENDMENT TRANSMITTAL LETTER</b>			Docket No. 8733.154.00 -US
Application No. 09/350,313	Filing Date July 9, 1999	Examiner Robert M. Kunemund	Art Unit 1765

Applicant(s): Jin JANG et al.

Invention: METHOD OF CRYSTALLIZING AMORPHOUS SILICON LAYER AND CRYSTALLIZING APPARATUS THEREOF

**TO THE COMMISSIONER FOR PATENTS**


Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

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CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	36	- 38 =		x	0.00
Independent Claims	4	- 6 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00

- ☒ Large Entity ☐ Small Entity
- ☒ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Commissioner is hereby authorized to charge and credit Deposit Account No. 50-0911  
as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
Teresa M. Arroyo  
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Dated: March 10, 2003

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